

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of  
ETSURO MORITA and AKIHIKO ENDO

Date: July 29, 2009

Serial No. : 10/587,725

Examiner: Candice CHAN

Filed : July 26, 2006

Group Art Unit: 2813

For : METHOD FOR MANUFACTURING SOI WAFER

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

In response to the Office action dated April 29, 2009, please consider the following amendments and remarks:

Amendments to the Specification	None
Amendments to the Claims	Begin on page 2
Amendments to the Drawings	None
Remarks	Begin on page 6